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In the United States Patent and Trademark Office

Serial Number: 10/708778

Application filed on: 2004 March 24

Applicant(s): Baokang Bi

Application Title: PATTEN GENERATING SYSTEMS

Examiner/GAU: /

Mailed on: 2004 April 5

At: Okemos, Michigan

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Very respectfully,

Applicant(s): Baokang Bi

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c/o: Baokang Bi, Applicant Pro Se

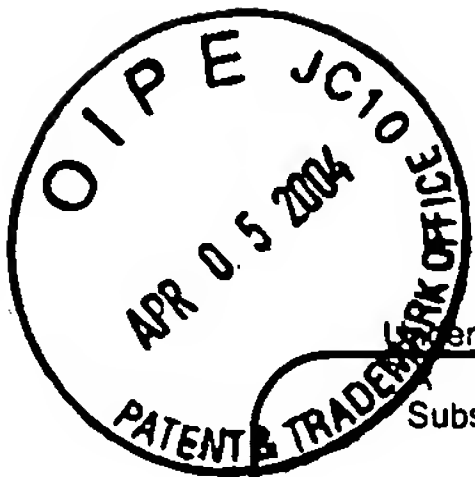
3928 E. Sunwind Drive, Okemos, MI 48864

Telephone: (517) 351-8614 Email: baokang_bi@yahoo.com

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Date: 2004 April 5, Baokang Bi, Applicant



Substitute for form 1449/PTO

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(Use as many sheets as necessary)

Complete if Known

Application Number	10/708778
Filing Date	2004 March 24
First Named Inventor	Baokang Bi
Art Unit	
Examiner Name	
Attorney Docket Number	

Sheet 1 of 4

U. S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
		WO 98/48443	10-29-1998	John Wiesner		
		WO 03/079116	09-25-2003	Pieter Kruit		

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NON PATENT LITERATURE DOCUMENTS			
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		Arnaud Bertsch, et al., "Rapid Prototyping of small size objects", Rapid Prototyping Journal, Vol.6, p259, 2000.	
		http://www.micronic.se/site_eng/product/multiexposure.shtml , Publication date on website is unknown.	
		H. J. Tiziani, et al., "Theoretical Analysis of Confocal Microscopy with Microlenses", Applied Optics, Vol. 35, p120, 1996.	
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		H. J. Tiziani, et al., "Three-Dimensional Analysis by a Microlens-Array Confocal Arrangement", Applied Optics, Vol. 33, p567, 1994.	
		Neha Choksi, et al., "Maskless extreme ultraviolet lithography", J. Vac. Sci. Technol. B 17, p3047, 1999.	
		http://pguerit.sri.com/SriWeb/current/DPS.html , "Direct photo shaping", Publication date on website is unknown.	
		Srinivas Bollepalli, et al., "Image formation in extreme ultraviolet lithography and numerical aperture effects", J. Vac. Sci. Technol. B(17), p2992, 1999.	

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		Ihsan Djomehri, et al., "Zone-plate-array lithography in the deep ultraviolet", J. Vac. Sci. Technol. B(16), p3426, 1998.	
		J. W. Gardner, "Microsensors, MEMS, and Smart Devices", John Wiley & Sons, Ltd., New York, 2001, Chapter 7.	
		Dario Gil, et al., "Parallel maskless optical lithography for prototyping, low-volume production, and research", J. Vac. Sci. Technol. B(20), p2597, 2002.	
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		Eiichi Tamaki, "Computer-to-plate printing using the Grating Light Valve(TM) device", Proceedings of SPIE, Vol. 5348, p89, 2004.	
		Stephen D. Senturia, "Microsystem Design", Kluwer Academic Publishers, Boston, 2000, Chapter 20.	

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		Jahja I. Trisnadi, et al., "Overview and applications of Grating Light Valve (TM) based optical write engines for high-speed digital imaging", Proceedings of SPIE, Vol. 5348, p52, 2004	
		R. W. Corrigan, et al., "Grating Light Valve (TM) Technology for Projection Displays", International Display Workshop, Kobe, Japan, December 1998.	
		L. Hornbeck, "Digital Light Processing (TM) for High -Brightness, High-Resolution Applications", Proceedings of SPIE, Vol.3013, p27, 1987.	

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